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X-RAY SCATTERING INVESTIGATION OF MICROALLOYING

AND DEFECT STRUCTURE IN ION IMPLANTED COPPER

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The double-crystal method for x-ray scattering analysis of radiation described by B. C. Larson (1) has been applied to the investigation of aluminum implanted copper. The interpretation of x-ray observations is based on effects of lattice strain in the surface microalloy and the presence of dislocation loops which originate from implantation damage. The copper crystal with a dislocation less than 10^3 cm/cm³ was implanted with aluminum to a dose of 2×10^{16} ions/cm with energies up to 200 keV. The response of the implanted crystal to annealing at 500 C and 600 C was determined. The quantitative use of the x-ray technique to assess implantation effects and the limitations of the technique are discussed.

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Introduction

X-ray diffraction is an effective method for analyzing radiation damage particularly for quantitative measurement of lattice strain effects associated with defect clusters (1). In recent years there have been a variety of x-ray diffraction investigations of ion implantation damage produced in single crystals based on double-crystal measurements. Komenou et al. (2) observed x-ray scattering Pendellosung interference in rocking curves from Ne^+ -implanted garnet films which Speriousu (3) interpreted according to a kinematic diffraction theory incorporating strain and damage distributions as a function of depth. Afanasev et al. (4) have used dynamical theory for calculating the scattering from a silicon crystal with disturbed layers. Yamagishi and Nittono (5) studied Ar^+ -ion-implanted copper whiskers with both x-ray topography and a triple-crystal diffraction method to assess lattice strain response with dose and annealing. In the foregoing studies (2-5) no absolute intensity measurements were made so that analysis of structural changes depended mostly upon scattering distribution shape. In the present study, absolute reflectivity measurements are used to study the effects of Al^+ -ion damage in copper due to low energy (200 keV) and high dose (2×10^{10} ions/cm²) using a double-crystal diffraction method. Both surface alloying and implantation damage are under consideration for their important influence on fatigue crack initiation (6). Because radiation damage production of point defect clusters enters our work in a fundamental way, this paper offers an example of the utility of x-ray scattering techniques in radiation damage research.

The principle challenge in this x-ray study was to find an effective x-ray method for investigating the damage and surface alloying effect in an implanted layer which is much thinner than the sampling depth of x-rays. In addition, there was the consideration of which theoretical analysis of scattering intensity would be most appropriate to describe the combined damage and surface alloying scattering effects. This question was approached from two perspectives; (a) use of dynamical theory of diffraction for the analysis of lattice strain due to surface alloying (7,8) and (b) use of kinematic theory for the description of scattering from defect clusters (1). It is shown that the scattering data are dominated by implantation damage defect clusters and that the kinematic theory is most appropriate for the description of scattering in the case at hand. Furthermore, it is shown that a quantitative evaluation of implantation damage can be obtained from the absolute reflectivity measurements made in the double-crystal method.

X-Ray Scattering Models

The structure the implanted region is modeled by placing of point defect clusters within a surface layer which has a lattice parameter that is expanded by implantation alloying. As yet, no single formulation for scattering intensity gives a calculation of the scattering from the combined defect cluster and lattice distortion effects. Instead, we make a calculation for the case of scattering from a defect-free surface alloy on one hand and a calculation for the scattering from defect clusters in a unalloyed matrix on the other hand. The measured x-ray scattering effects are then used to determine the manner in which the two calculations might be applied to represent the scattering from the implanted layer.

For a surface alloy layer free of defects, the dynamical theory of x-ray scattering can be used to calculate the reflectivity of x-rays as a function of crystal rotation in a double-crystal rocking curve. In a two-crystal arrangement, the first crystal which is not implanted is set to maximum reflectivity. The second crystal is rotated about an axis perpendicular to the scattering plane (defined by the incident and reflected

x-ray beams.) The resulting reflectivity curve is the convolution of the reflection characteristic of the first crystal with the reflectivity of the second crystal. Larson (7,8) has adapted, for this surface alloy problem, a method of calculation used by Klar and Rustichelli (9) for neutron scattering from elastically bent crystals. The reflectivity from a crystal is obtained by the computation of the real and imaginary components of the complex scattering amplitude of the reflected radiation. Two coupled differential equations - one for real and one for imaginary components - are integrated numerically. The integration is dependent upon initial values of the amplitude components and the variation in the Bragg angle for the crystalline sublayers due to the elastic lattice distortion arising from bending or composition change. Full algebraic development of the theory can be found in papers by Larson and Barhorst (8) and Klar and Rustichelli (9). The equations requiring integration express the derivatives of the real (X_1) and imaginary (X_2) scattering amplitude components with respect to a variable A which is proportional to depth measured relative to the external surface:

$$\frac{dX_1}{dA} = k(X_1^2 - X_2^2 + 1) + 2X_2(X_1 - y) - 2gX_1 \quad (1)$$

$$\frac{dX_2}{dA} = -(X_1^2 - X_2^2 + 1) + 2X_1(kX_2 + y) - 2gX_2 \quad (2)$$

where k and g are constants which depend on x-ray absorption and the parameter y contains the misfit angle, $\Delta\theta$, for the rocking curve as follows:

$$y = C_1 \Delta\theta - C_2 \quad (3)$$

where C_1 and C_2 are constants dependent on x-ray scattering parameters that are fixed for the Bragg diffraction peak under examination. For the case where the lattice parameter varies with A it is shown (8) that

$$y = C_1(\Delta\theta + \epsilon(A)\tan\theta_B) - C_2 \quad (4)$$

where the variation of the lattice parameter with depth is contained in the strain function $\epsilon(A)$. In the case at hand, $\epsilon(A)$ is determined by the composition of the surface alloy as a function of implantation depth.

The method by which the change in reflectivity due to surface alloying is calculated does not require integration over the entire crystal thickness. Instead, one uses the well known results (10,11) for the reflectivity from a perfect crystal as a starting point. The real and imaginary components of the scattering amplitude at a set rocking angle are used as initial values for the integration beginning at a depth below the implanted ions. For the integration back to the surface the effects of surface alloying, $\epsilon(A)$, are allowed to affect the computation of scattering amplitude. A set of these calculations is done for a range of rocking angles where the reflectivity is calculated from,

$$R(\Delta\theta) = X_1^2 + X_2^2 \quad (5)$$

where the amplitude components, X_1 and X_2 , are evaluated at the reflecting crystal surface. Note that the result is an absolute reflectivity value.

Figure 1 shows the calculated results we have obtained at the reflecting in which 2 atomic percent of aluminum is implanted in copper to a depth of approximately 1000 Å. The lattice parameter expansion used in the calculation was taken from the data given on linear lattice strain by King (12) equal to +0.0626 per atomic percent of aluminum in copper. A sharp

subsidiary peak of 1.4 percent reflectivity is seen at a Bragg angle displaced to a lower angle than the substrate Bragg angle corresponding to the expanded lattice parameter. The small peak width is approximately 2 minutes of arc. The reflectivity is the order of the ratio of implanted layer thickness to the x-ray penetration thickness, $1/2\mu_0$, where μ_0 is the linear absorption parameter.

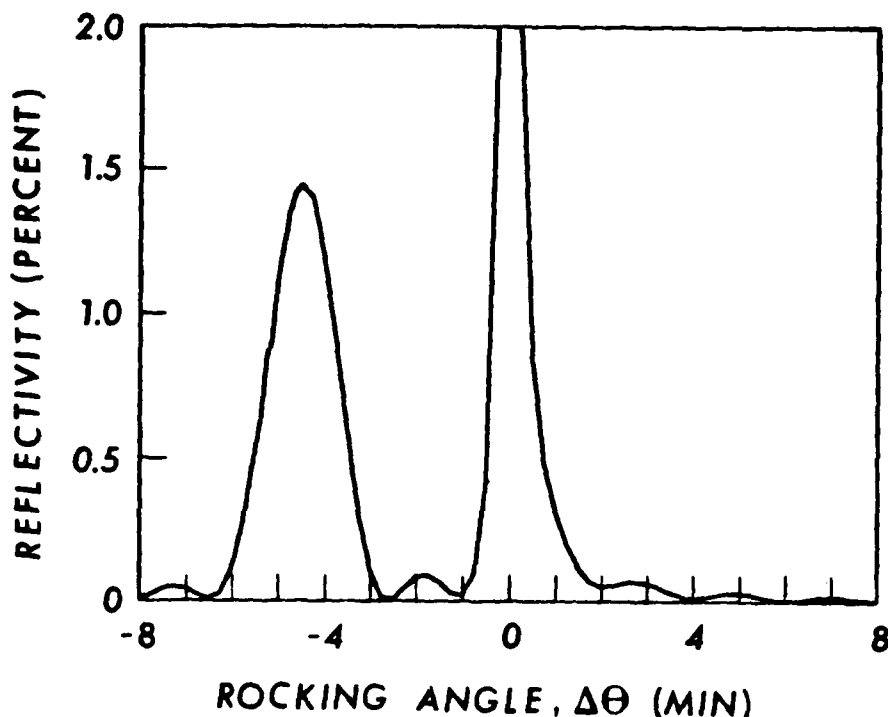
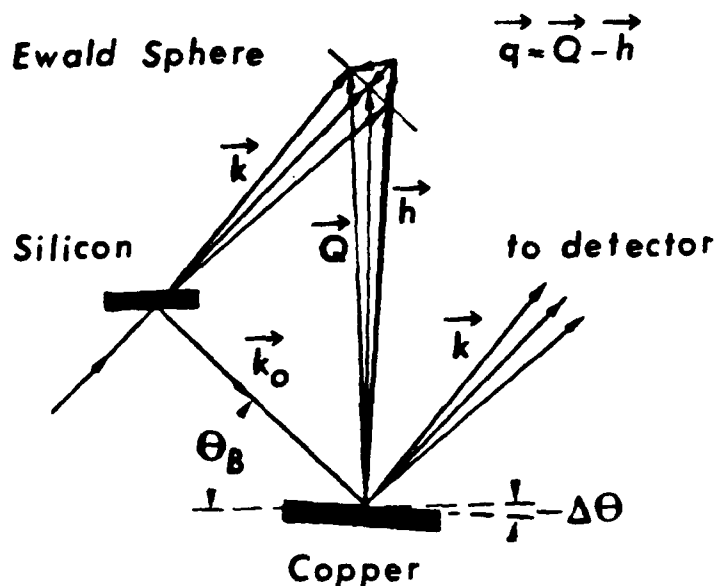


Fig. 1 Calculated reflectivity from a surface implanted to 2 atomic percent of aluminum in copper to a depth of approximately 1000 Å. The subsidiary peak appears at an angle appropriate for the lattice parameter of this composition.

Consider now the calculation of the scattering from defect clusters in a crystal of uniform lattice parameter. In this case, kinematic diffraction theory is used to calculate the scattering intensity from an isolated defect cluster. The scattering resulting from a collection of defects is the sum of the intensities. This implies that no scattering interference occurs between scattering amplitudes coming from each defect. Larson (1) summarizes the calculation of the scattering intensity from defect clusters. The experimental geometry used in our experiments is shown in Figure 2 where the scattered x-rays are received by a large detector. Each of the scattering vectors is associated with a scattering space vector, q , going from the Bragg spot (at the top) to the surface of the Ewald scattering sphere. In such an experiment, the intensity is averaged over the scattering space vectors, q . q_0 is the shortest vector between the Bragg position and the Ewald sphere at a given crystal setting. The measured intensity is called the integral diffuse scattering. The intensity is measured as a function of rocking angle of the crystal in the same geometry used for measurement of dynamical diffraction effects described above.

The diffuse scattering from dislocation loops measured close to the Bragg peak is attributed to long range strain fields around the loop and is called Huang scattering. Scattering measured farther away from the Bragg

Fig. 2
Scattering geometry for the double crystal method used in this experiment. Upon rocking the crystal the Ewald scattering sphere is swept through the Bragg point. At a fixed crystal setting the diffuse scattering is integrated over a portion of the scattering sphere near the Bragg point.



peak is attributed to short range strain fields and is termed Stokes-Wilson scattering. The diffuse scattering is distributed about the Bragg position in a way dependent on the precise strain field distribution (1,13). The calculation of integral diffuse scattering requires an averaging of the diffuse scattering over the portion of the Ewald scattering sphere which is close to the Bragg position (14). For the scattering from loops of radius R , the Huang scattering smoothly joins the Stokes-Wilson scattering at a scattering parameter $q_0 \approx q_L = a/R$ where $q_0 = h \Delta \epsilon \cos \theta_B$ with d_{hk} spacing, $h = 2\pi/d_{hk}$, θ_B the Bragg angle for reflection from the hkl planes, $\Delta \theta$, the misset angle of the rocking curve. A symmetric diffuse scattering cross section is defined

$$\sigma_h^S(q_0) = 1/2(\sigma_h^S(-q_0) + \sigma_h^S(q_0)) \quad (6)$$

which is obtained by the average of intensities measure symmetrically above and below the Bragg position ($q_0 = 0$). The symmetric diffuse cross sections for Huang and Stokes-Wilson scattering are given by,

$$\text{(Huang)} \quad \sigma_h^S(q_0) = (r_e^2 f_h^2 e^{-2M} (h/k)^2 2\pi \tau (b^2 R^2 / V_c)^2 \ln(e^{1/2} q_L / q_0)) \quad (7)$$

for $q_0 < q_L$, and,

$$\text{(Stokes-Wilson)} \quad \sigma_h^S(q_0) = (r_e^2 f_h^2 e^{-2M} (h/k)^2 2\pi \tau (b^2 R^2 / V_c)^2 q_L^2 / 2q_0^2) \quad (8)$$

for $q_0 > q_L$, r_e is the Thompson electron radius (2.82×10^{-13} cm), f is the scattering factor, e^{-2M} is the Debye-Waller factor, $k = 2\pi/\lambda$, λ = wavelength, b is a constant of order 1 which depends on averaging of loop orientations, b = Burgers vector, V = atomic volume. The scattering intensity relative to the incident intensity is given by,

$$\frac{I^S(q_0)}{I_0} = \frac{C(R)}{2\mu_0 V_c} \sigma_h^S(q_0) \quad (9)$$

where $C(R)/V_c$ is the density of loops of radius R . From Eqns. (7), (8) and (9) one can obtain loop size and density. Note that $(b^2 R^2 / V_c)$ equals the number of point defects in the defect cluster.

In summary of the two calculations, the dynamical theory predicts a subsidiary peak which appears at an angle determined by the lattice strain due to alloying. The kinematic theory predicts a diffuse scattering which is proportional to the number and size of loops. Both calculations give the absolute relectivity with no adjustable parameters other than those describing the structure. The dynamical theory calculation depends on the assumption that the surface alloy is crystallographically coherent with the unalloyed crystal. The kinematic theory is likely to be limited in the case of very high defect cluster densities where nonrandom loop distributions may lead to interference between diffuse scattering amplitudes.

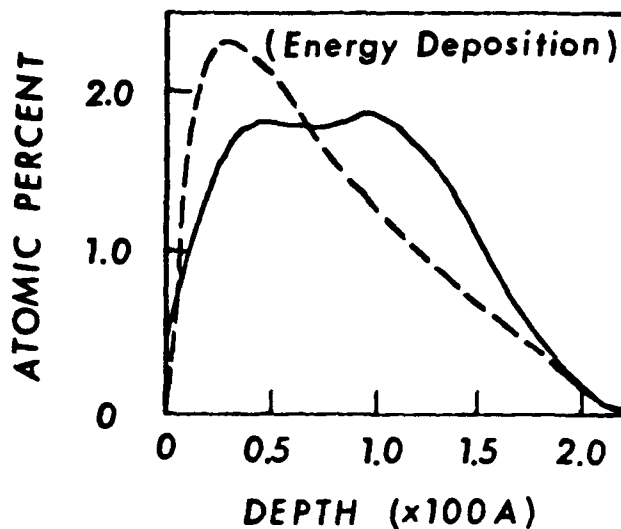
Experimental

The calculated strain scattering effects must be measured at small angles near the Bragg diffraction peak of the unaffected crystal. The implant affected region is less than 1 micron and the penetration depth is approximately $1/2 = 11$ microns. It is required that the bulk of the crystal be perfect (mosaic spread less than 1 minute) in order that the small scattering effects can be measured near the Bragg peak. Furthermore, it is required to subtract a significant background due to the tails of the bulk crystal Bragg peak in order to determine the diffuse scattering intensity due to surface alloying and defect clusters. A convenient approach to this measurement is to translate the crystal between an implanted and implantation-free area on the same crystal. Crystals used in these studies were provided by F. W. Young of Oak Ridge National Laboratory. The crystals were grown by the Bridgeman technique, cut to orientation, then annealed at a few degrees below the melting point for two weeks. The crystal pieces were hardened by neutron irradiation and then further cut and shaped by chemical cutting methods (15). The dislocation density measured by etch pit techniques was less than 10^5 cm^{-2} after shaping procedures were completed.

The two-crystal arrangement consisted of a silicon crystal fixed to diffract the Cu K_α radiation onto the implanted copper crystal. The (333) d-spacing (1.0451 Å) of silicon happens to match the (222) d-spacing (1.0436 Å) of copper very well so that the system is well focussed to give a narrow rocking curve width. The copper crystal is initially aligned to give a sharp maximum in the rocking curve by adjusting the (111) normal about an axis in the scattering plane. When properly adjusted, the full width at half-maximum (FWHM) of the copper rocking curve is 12.5 arc-seconds. The crystal is mounted on a goniostat which can be translated in the plane of the crystal surface so that rocking curves can be made from the implanted area and masked implantation-free areas. In a typical run, the copper crystal is rocked about an axis perpendicular to the scattering plane at a rate of 5 to 20 arc-seconds per minute while x-ray intensities are recorded continuously at 10 second intervals. The x-ray detector has an active receiving area of 5 cm^2 at a distance of 8 cm so that the subtended solid angle (0.08 steradians) integrates the scattering over a large portion of the Ewald sphere in the vicinity of the 222 Bragg peak of copper.

The implantation of aluminum into copper was chosen for these experiments because the ion penetration was favorable and the microalloy concentration was well below the solubility limit of the aluminum in copper. The details of implantation are given elsewhere (19). The implanted layer was 1200 Å thick (16) with a composition of 1.8 atomic percent. The distribution of damage over the alloy thickness was estimated on the basis of calculations by Fritzsche (17) and Winterbon (18). The alloy distribution (solid line) and the damage profile (dashed line) are shown in Figure 3.

Fig. 3
Distribution of implanted Al^+ ions (solid) and the energy deposition (dashed) for the implantation of 2×10^{16} ion/cm² with energies up to 200 keV. Note that damage is concentrated toward the surface and that the damage energy is on a relative scale.



Annealing of the specimens was performed as a means to differentiate the sources of scattering in the implanted layers. The crystals were placed in a vacuum of 10^{-8} Torr at 500 C, 600 C and 900 C for 30 minutes. Annealing at 900 C restored the original structure as seen in the rocking curves.

Fig. 4
Rocking curves are shown for the implanted (upper) and implantation-free (lower) crystal. The scattering is expressed as a fraction of the incident beam intensity. Note the larger scattering at low angles.

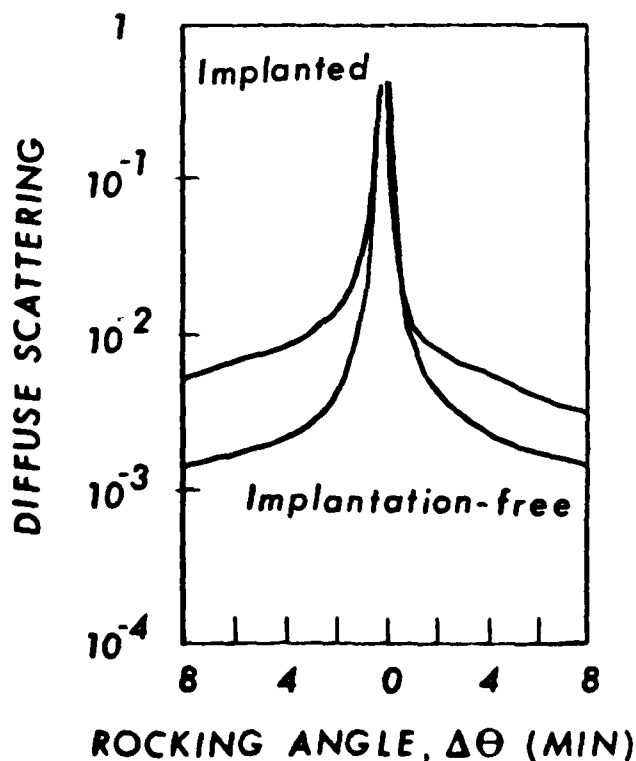


Fig. 5
Excess diffuse scattering intensity for the sample before annealing (dashed) and after annealing (solid) at 500 C. Note that little change in the general level and distribution of the excess intensity occurs upon annealing.

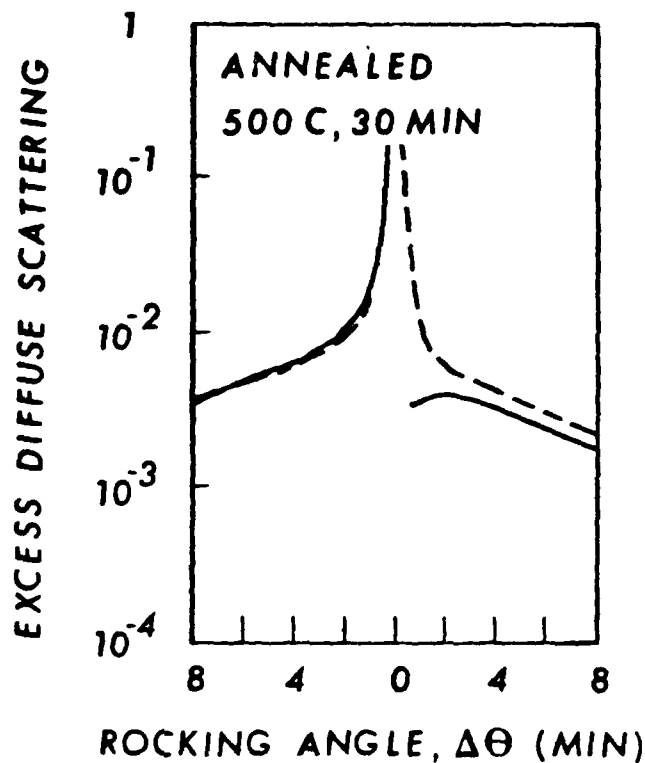
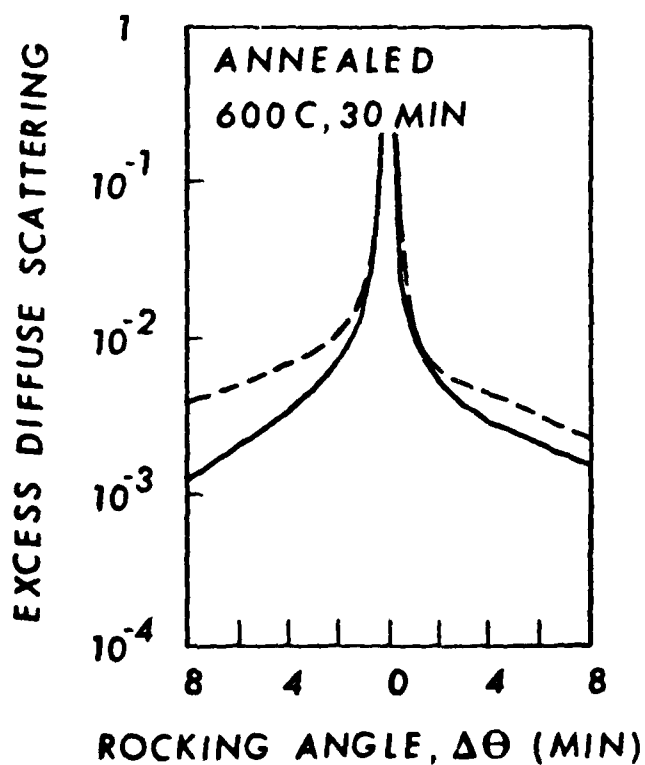


Fig. 6
Excess diffuse scattering intensity for the sample before annealing (dashed) and after annealing (solid) at 600 C. The level and the distribution of the excess intensity changes as a result of the annealing at this temperature.



Results and Discussion

The rocking curves for implantation-free copper and for aluminum implanted copper were measured on the same crystal. These curves are shown in Figure 4. The diffuse scattering from the implanted crystal is more intense on the low angle side of the Bragg peak position. The excess diffuse scattering is calculated by subtraction of the implantation-free rocking curve intensity from the corresponding intensity in the implanted crystal. The excess diffuse scattering for the implanted crystal is shown in Figures 5 and 6 as a dashed line. The effect of 30 minute anneals on the excess diffuse intensity is shown in Figure 5 for annealing at 500 C and in Figure 6 for annealing at 600 C. No large change due to annealing occurs at 500 C while for annealing at 600 C, there is a reduction of scattering and scattering becomes more symmetric with respect to the Bragg peak position.

The observation of a higher diffuse scattering at low rocking curve angles can be attributed to the fact that implanted aluminum expands the copper lattice so that Bragg scattering from the implanted region occurs at a lower angle than that for the implantation-free material. The composition of the implanted layer was estimated to be 1.8 atomic percent. The resulting Bragg position would be displaced to lower angle by 4.2 minutes for the 222 reflection from the copper alloy layer.

The diffuse scattering seen on both sides of the main Bragg position can be compared to calculations of the scattering from dislocation loops. In Figure 7 the excess diffuse scattering is plotted versus the log of the rocking angle according to Eqn. (7) for Huang loop scattering. The rocking angle was measured relative to the supposed Bragg position for the alloy.

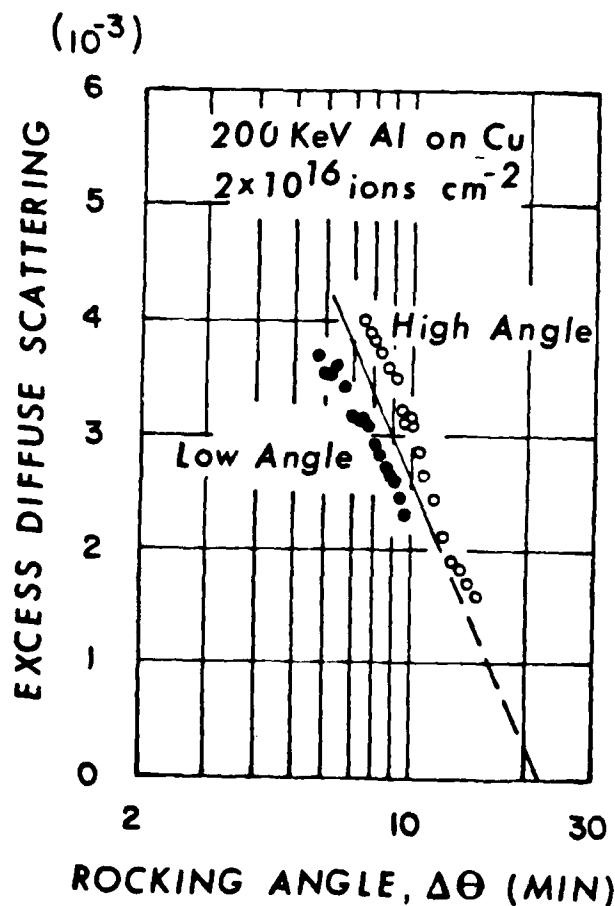


Fig. 7
The excess diffuse scattering from the implanted crystal is plotted versus $\ln(\Delta\theta)$ for the intensity above and below the Bragg position assumed to apply for the implanted region of the crystal.

Although there is a displacement between the two sets of points, the average of the high angle and low angle intensity is close to a straight line which yields an estimated loop radius of 25 Å.

An estimate of the density of loops can be made by comparing measured reflectivity with Eqn. (9). We use a loop radius of 25 Å and a reflectivity of 1 percent at $\Delta\theta = 2$ minutes. Substitution of appropriate constants into Eqn. (9) for a 25 Å loop size gives

$$\frac{I^S(q_0)}{I_0} = 6.1 \times 10^{-21} \frac{C}{V} \ln\left(\frac{44}{\Delta\theta(\text{min})}\right) \quad (10)$$

from which a value of C/V is 5.3×10^{17} loops/cc. (The loops are concentrated by a factor of 40^C in the implanted layer since the above calculation assumes the loops to be uniformly distributed).

The failure to observe a sharp Bragg peak associated with the implanted aluminum and the general agreement with scattering levels calculated for loop scattering point to the conclusion that the kinematic theory for diffraction from an implanted crystal containing loops is appropriate. The annealing at 600 C produces symmetrical scattering which suggests that most of the aluminum is removed from the region where loops persist. Thereby the loop scattering now originates in essentially pure copper. The role of aluminum is seen as simply expanding the lattice in a region where loops persist which, by virtue of severe damage, is no longer strictly coherent with the implantation-free crystal.

Conclusions

Analysis of x-ray diffraction in aluminum-ion implanted copper suggests that defect cluster scattering dominates the observed rocking curve intensity. Alloying in the implanted layer contributes through a shifting of the diffuse scattering to lower angles due to the fact that the defect clusters are formed in a region of aluminum-expanded lattice. The formation of a distinct peak predicted by dynamical diffraction theory does not occur, probably because of the intense defect scattering and the widths of the peak from the thin layer. Problems in the analysis of scattering remain in the area of formulating a model of combined alloying and defect cluster scattering as well as description of very high defect cluster scattering. Nevertheless the simplistic interpretation of x-ray scattering observation provides useful insights into the type and quantity of damage as well as the annealing response of the implanted structure. Measurements carried out to larger q_0 will be useful in further definition of the defect structure since Bragg scattering from the implantation-free and implanted layer are avoided and the kinematical theory can be assumed. Size distributions and total point defect densities are more directly measurable at the larger q_0 values (1) as well.

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